


<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>			Docket No. FIS920030051US1
Applicant(s): Steegan et al.			
Application No. 10/604,102	Filing Date 6/26/2003	Examiner Eckert II, George C.	Group Art Unit 2815
Invention: SELECTIVE SILICON-ON-INSULATOR ISOLATION STRUCTURES AND METHOD			
<div style="text-align: right;">RECEIVED CENTRAL FAX CENTER DEC 22 2004</div> <p>I hereby certify that this _____ <u>Request for Reconsideration (16 pages)</u> _____ (Identify type of correspondence) is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>) on <u>12/22/2004</u> (Date)</p> <div style="text-align: center;"><p>_____ Kim Dwileski (Typed or Printed Name of Person Signing Certificate)</p><p> (Signature)</p></div> <p>Note: Each paper must have its own certificate of mailing.</p>			

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.: 10/604,102

Applicant(s): Steegan et al.

Filed.: June 26, 2003

Art Unit: 2815

Dkt. No.: FIS920030051

Examiner: Eckert II, George C.

Title: **SELECTIVE SILICON-ON-INSULATOR ISOLATION STRUCTURES AND METHOD**

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Honorable Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

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**REQUEST FOR RECONSIDERATION**

This Request for Reconsideration is being filed in response to the Office Action mailed on October 5, 2004.

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